

DeltaQualifikationsMatrix

Allgemeines

Kurze Produkt- und Technologiezyklen elektronischer Bauelemente sowie neue Umweltauflagen führen häufig zu prozess- und werkstofftechnischen Änderungen an Bauelementen, Leiterplatten, Verbindungstechnik und Schaltung, welche evaluiert werden müssen. Eine geeignete Methodik zur Handhabung von Änderungen an elektronischen Bauelementen beschreibt die ZVEI "Guideline for Customer Notifications of Product and /or Process Changes (PCN) of Electronic Components specified for Automotive Applications". Ein wesentlicher Teil dieser Guideline sind die hier vorliegenden Matrizen, welche sich als Empfehlungen für die Evaluierung von typischen Änderungen an elektronischen Bauelementen verstehen. Dies sollte Teil des offenen und risikobewussten Dialogs zwischen Lieferant und Kunden sein. Diese DeltaQualifikationsMatrizen wurden durch den Industriearbeitskreis "PCN DeltaQualifikationsMatrix" und den Bauteilexperten des ZVEI Arbeitskreises "PCN-Methodik" erarbeitet. Der Inhalt wurde basierend auf dem aktuellen Stand der Technik erstellt und erhebt keinen Anspruch auf Vollständigkeit. Im Einzelfall ist ggf. ein abweichendes Vorgehen abzustimmen, da kundenspezifische Vereinbarungen zur Qualifikation zu berücksichtigen sind.

Anwendung der DeltaQualifikationsMatrix (auszufüllen durch den Bauelementhersteller)

- Diese Tabelle ist nur bei Änderungen anzuwenden. Neuqualifikationen und Sonderqualifikation (z.B. Verfuß von Modulen) sowie Information Notes bleiben von diesen Matrizen unberührt.
- Ist eine Änderung in dieser Tabelle nicht aufgeführt, so ist der Qualifikationsumfang zwischen Kunde und Lieferant abzustimmen.
- Die Matrix der Aktiven Bauelemente ist so aufgebaut, dass zwischen integrierten Halbleitern (AEC-Q100 Rev. H) und diskreten Halbleitern (AEC-Q101 Rev. D1) auszuwählen ist (Zelle D4). Für passive Bauelemente gilt die AEC-Q200. Für LED's gilt die AEC-Q102. Für Multi-Chip-Module gilt die AEC-Q104.
- Alle Änderungen in der PCN sind in der Spalte B durch ein Kreuz (x) zu markieren und werden dadurch farblich hervorgehoben. Sofern dies geschehen ist, werden im Feld "Tests, which should be considered for the appropriate process change" alle in Betracht zu ziehenden Zuverlässigkeitstests angezeigt.
- In "Tests, which should be considered for the appropriate process change after selection of condition table" wird die Anpassung der in Betracht zu ziehenden Tests in Folge der Relevanz bezüglich der Änderung berücksichtigt. Dazu ist die Tabelle "Conditions" entsprechend der Auswahl (A/B/C) mit einem (x) zu bewerten.
- In "Suppliers performed tests" dokumentiert der Bauelementhersteller die durchgeführten bzw. geplanten Tests.
- Falls von der Testempfehlung abgewichen wird, so sollten diese Abweichungen vom Bauelementhersteller angezeigt und kommentiert werden. Hierzu ist der Bereich "Reason for exception of tests" zu verwenden. Werden die in Betracht zu ziehenden Tests durch generische Daten (G) belegt, ist dies ebenfalls hier anzuzeigen und zu begründen.

Die Einstufung des Untersuchungslevel erfolgt in folgende Kategorien

- "C: Component level":** Die Evaluierung der Änderung am Bauelement ist durch Untersuchungen ausschließlich am Bauelement beim Bauelementhersteller durchführbar. Zur Evaluierung der Änderung dürfen Ergebnisse aus bereits durchgeführten Untersuchungen herangezogen werden, wenn diese zu einem ähnlichen Bauelement bereits vorliegen (**Generische Daten**).
- "B: Board level":** Die beschriebene Änderung hat möglicherweise Einfluss auf die Verarbeitbarkeit des Bauelementes im Steuergerät. Die Evaluierung der Änderung wird wie unter C beim Bauelementhersteller durchgeführt. Zusätzlich ist durch den Kunden/Steuergerätehersteller die Verarbeitbarkeit zu prüfen, die z.B. abhängig von der Änderung, Zuverlässigkeitsuntersuchungen auf applikationsrelevanten Testboards erfordert.
- "A: Application level":** Die beschriebene Änderung hat möglicherweise Einfluss auf die Applikation/ das Steuergerät. Die Evaluierung der Änderung wird wie unter C oder B durchgeführt. Zusätzlich ist vom Kunden/Steuergerätehersteller der Einfluss der Änderung im Steuergerät durch geeignete Untersuchungen zu bewerten. Dieses Vorgehen ist mit dem OEM abzustimmen. Hierbei ist zu berücksichtigen, ob die Steuergeräte- / Baugruppenanforderungen durch andere Qualifikationen bereits hinreichend abgesichert sind (**applikationsspezifische Risikobetrachtung**).
- "*": Not relevant for qualification matrix":** Änderung(en), die nicht in A, B oder C eingestuft werden können und somit nicht relevant für die DeQuMa sind

Information Notes

Änderungen die nur eine Information Note benötigen (bei der Bewertung Risk on Supply Chain als "I" gekennzeichnet), dürfen nicht in der DeQuMa angekreuzt werden, da Sie ansonsten den erforderlichen Evaluierungslevel verfälschen. Für als "I" bewertete Änderungen ist das Information Note Formblatt zu verwenden.

Wichtige Hinweise

- Zur formgerechten Anwendung der DeltaQualifikationsMatrizen steht auf der Homepage des ZVEI AK ein Tutorial bereit (ZVEI-Tutorial).
- ID Nummer: ist eine eindeutige Identifikationsnummer für jede angegebene Änderung, die in den ZVEI PCN DeltaQualifikationsMatrizen identifiziert ist. Die gleiche ID Nummer wird zur Identifizierung der Änderung im PCN Form Sheet verwendet.
- Die mittels Matrix identifizierten Tests sind in **Betracht zu ziehen**, d.h. es ist zu prüfen, ob der jeweilige Test für die spezifische Änderung in dieser Form notwendig ist. Abweichungen oder generische Daten sind im Detail zu begründen.
- Die Spalte "Further applicable conditions", Bemerkungen und Fußnoten sind unbedingt zu beachten, da sie wichtige Hinweise und Einschränkungen enthalten.
- Zur Nutzung aller Funktionen muss in Excel die Anwendung von Makros freigegeben sein.

Form provided by ZVEI - Revision 4.1 - November 2019

DeltaQualificationMatrix

General

Short product and technology cycles as well as new environmental regulations frequently result in process and material changes of components, printed circuit boards, assembly techniques and circuit layout which have to be evaluated. The ZVEI "Guideline for Customer Notifications of Product and /or Process Changes (PCN) of Electronic Components specified for Automotive Applications" describes an appropriate methodology for dealing with changed electronic components. The qualification matrices in this guideline are recommendations for how to assess typical changes of electronic components. These recommendations promote an open risk-based discussion between supplier and customer regarding qualifications. The DeltaQualificationMatrices were developed by the Industry Task Force Team "PCN DeltaQualificationMatrix" together with component experts from the ZVEI Working Group "PCN-Methodology". Actual content represents state-of-the-art technology and does not claim to be comprehensive. Deviation from proposed guideline should be mutually agreed as customer specific requirements have to be considered.

DeltaQualificationMatrix Application (completion by component manufacturer)

- This table has to be used for changes only. The matrices are not applicable for new product, special qualifications (for instance for encapsulation of module) or Information Notes.
- If a change is not listed in this table, the qualification plan has to be defined and agreed between customer and supplier.
- The matrix for Active Components requires the user to choose between integrated circuits (AEC-Q100 Rev. H) and discrete semiconductors (AEC-Q101 Rev. D1) (cell D4). For Passive Components AEC-Q200 is used. For LED'S the AEC-Q102 is used. For Multi-Chip-Modules the AEC-Q104 is used.
- All changes as listed in the PCN have to be marked by a cross (x) in column B and will appear colored. The relevant reliability tests are then shown in "Tests, which should be considered for the appropriate process change".
- In "Tests, which should be considered for the appropriate process change after selection of condition table" is for modification of the found relevant tests under consideration of the weight of change. Related table "Conditions" has to be assessed per proposed letters with an (x).
- In "Suppliers performed tests" the component manufacturer documents the planned and performed tests.
- In case of deviations from tests, which should be considered this should be notified and commented by the component manufacturer in the area "Reason for exception of tests". Test results in form of generic data (G) are allowed when notified and justified.

Evaluation Levels are categorized as follows

- "C: Component level":** The evaluation of a change at component level by the component manufacturer is sufficient. Generic data from other relevant evaluations can be used.
- "B: Board level":** The intended change described in the PCN may influence processability / manufacturability of the component at board level. Therefore additional evaluation by customer may be necessary, for example reliability tests on application relevant testboards, depending on change.
- "A: Application level":** The intended change described in the PCN may influence the properties of the application (e.g. Electronic Control Unit). In addition to the evaluation under C or B the influence of the change in the application is evaluated by suitable investigations by the customer. The scope of the evaluation has to be aligned with the OEM. It has to be considered whether the application / assembly requirements are already sufficiently safeguarded by other qualifications (**application specific risk assessment**).
- "*": Not relevant for qualification matrix":** Changes which fulfill neither A,B nor C definitions

Information Notes

Changes indicated as "I" shall not be marked in the DeQuMa. For those changes the Information Note sheet shall be used. As the DeQuMa is desired for PCN only, a marking of "I"-changes would automatically influence evaluation level and test effort.

Important Notes

- To use the matrices in the right form the ZVEI working group provides a Tutorial on its homepage (ZVEI-Tutorial)
- ID number: is a unique identification number for each indicated change defined in the ZVEI PCN DeltaQualificationMatrices. The same ID number is used in the PCN Form sheet to identify the change.
- Tests identified by the matrix have to be **considered** and checked if they are necessary to assess the specific change. Test modifications or generic data have to be justified in detail.
- "Further applicable conditions", comments and notes need attention, as they provide important hints and limitations.
- In order to use all functions in EXCEL, macros have to be allowed.

History of DeQuMa

Version	Remarks
2.0	Revised by ZVEI PCN Methodology Workgroup in March 2015
2.1	Released March 2015
2.1.1	Active Components - delete write protection in comments
2.2	Solved problems with some ActiveX configurations
2.2.2	Solved Problems in Active Components
2.2.3	Solved Problems ActiveX, Active Components SEM-DE-02 (Design changes in routing) error fixed
2.2.4	Minor fixes
3.0	General Revision by ZVEI PCN Methodology Workgroup in June 2016 Changes are indicated by underlining in the read only version named Changes_DeQuMa_rev3_vs_rev2.xlsx
3.0.4	Expert Release
3.0.5	Fixing of macro bugs
3.1	Final Release (orthographic and punctuation corrections)
4.0	General Revision by ZVEI PCN Methodology Workgroup in July 2019. Muliti Chip Modules newly added to DeQuMa LED Components now based on the AEC Q102 Further Changes see separate PDF's <u>Excel-File</u> , where changes are indicated by underlining
4.1	LED worksheet: Content of columns had been swapped due to rearrangement and omission of columns.

Worked on: (Name, Function)	
Date:	
PCN number:	
Signature:	
For integrated circuits or discrete semiconductors select below:	AEC-Q100 Revision H

Form provided by ZWSI - Revision 6.1 - November 2019

AEC-Q100 Revision H		MATERIAL PERFORMANCE TEST RESULTS (on the basis of AEC-Q100 Revision H)		Additional to AEC-Q100	Remarks
includes integrated circuits (e.g. ASICs, μ-Controller, memories, voltage regulators, smart power devices, logic devices, analog devices,...)					
Device evaluation					
Change of material (30 new materials only)					
ANY	Any change with impact on agreed upon technical contractual agreements	P	P	Intended to be used if no other type of change is applicable but the change of agreed technical contractual agreements	-
SEM-AN-01	Any change with impact on processability/manufacturability of customer, which is not covered in the matrix below	P	P	Any change which is not covered in the matrix below, but has assessment at customer's responsibility	B
SEM-AN-02	Any change with impact on processability/manufacturability of customer, which is not covered in the matrix below, but has assessment at customer's responsibility	P	P	Any change which is not covered in the matrix below, but has assessment at customer's responsibility	B
DATA SHEET	Change of sheet parameters/mechanical specification (min./max./typ. values) and/or AC/DC specification	P	P	Update of data sheet because of technical change of the product	A
SEM-DS-01	Change of sheet parameters/mechanical specification (min./max./typ. values) and/or AC/DC specification	P	P	Update of data sheet because of technical change of the product	A
SEM-DS-02	Correction of data sheet or issue of errata	I	I	Has technical change of product, process or test New description of material which was not specified before or which is different from initial specification Please indicate clearly, that reference contains this type of change	A
SEM-DS-03	Specification of additional parameters	I	P	Description of a new not previously covered parameter, for technical change of the product (P) Definition of new parameter which was not covered in the product (I) No known as single change. Only in conjunction with other changes	A
DESIGN	Design changes in active elements (1)	P	P	Any device relevant changes in design / layout of elements with effect on data sheet 1 Not included: EMC related to input/output connector with specific test process, vendor and design rules	A
SEM-ED-01	Design changes in active elements (1)	P	P	Any device relevant changes in design / layout of elements with effect on data sheet 1 Not included: EMC related to input/output connector with specific test process, vendor and design rules	A
SEM-ED-02	Design changes in routing (2)	P	P	Any change of wiring between elements in chip design. Not an effect on data sheet 2 Not included: Addition or deletion of pads/parameters without specific test design rules	C
SEM-ED-03	The shape (3)	P	P	Stroke of active area 3 Not included: saving street/land/trace line	A
SEM-ED-04	Firmware modification	I	P	Integrated software by design or memory as delivered by supplier (P) Firmware modification or update without effect of functional performance at the customer's responsibility (I) Firmware modification or update with effect of functional performance at the customer's responsibility	A
PROCESS / WAFER PRODUCTION	Change of wafer or substrate material	P	P	Not a different wafer material to currently assessed material (e.g. change from EPF material into non-EPF material)	C
SEM-PW-01	New wafer or substrate material	P	P	Not a different wafer material to currently assessed material (e.g. change from EPF material into non-EPF material)	C
SEM-PW-02	New wafer diameter	P	P	Change of wafer diameter resulting in equipment and process changes	C
SEM-PW-03	New wafer thickness	P	P	Change in wafer thickness e.g. change in final chiplet thickness	C
SEM-PW-04	Change of electrically active doping/implantation element	P	P	Change in electrically active doping / implantation element resulting in a new technology	A
SEM-PW-05	Change of gate material and / or gate dielectric material	P	P	Change of gate material and / or gate dielectric material	A
SEM-PW-06	New / change of backside operation (grinding / metallization)	P	P	Change of bottom layer or die between die and lead/frame. Change in process, material, or thickness necessary Alternative: see SEM-PW-07	C
SEM-PW-07	New / change of metallization / via / contacts	P	P	Change in metallization of bondpads, material, via or thickness specifically for die bondpads and internal vias	C
SEM-PW-08	New / change of passivation or the coating (without bare die)	P	P	Change of top layer or die between metal compound and die	C
SEM-PW-09	Change in process technology not covered by any other type of change	P	P	Change in process technology due to technical change of the final product (P) If the change in process technology can affect the integrity of the final product (I) If the change in process technology cannot affect the integrity of the final product	A
SEM-PW-10	Process integrity: tuning within specification	P	P	Adjustment within process specification (e.g. by tuning within process specification does not affect the integrity of the final product)	C
SEM-PW-11	Change of wafer or supplier	P	P	Change of wafer or supplier with same material composition and does not affect electrical behavior (P) e.g. new supplier with impact on substrate material and / or electrical behavior	C
SEM-PW-12	Change of specified wafer process sequence (optional and/or additional process step)	P	P	Any change which is not covered by another type of change. Risk is to be assessed (e.g. the Risk for Supply chain) (P) Risk for Supply chain (if impact on product integrity)	C
SEM-PW-13	Move all or parts of production to a different wafer fab site	P	P	Other fab transition with additional changes (described above) Includes transfer as an additional site	A

Mark change with an "x"

Process	Code	Description	Impact	Category	Sub-category	Material	Process	Equipment	Software	Documentation	Other	Notes	
Packaging	PKG-FM-DC-03	Changes of inner construction - Inner Connection	1	P	Change of inner connection	A	Change from internal connection to welded connection	C	Check if MATERIAL is affected				
	PKG-FM-DC-04	Changes of inner construction - Surface finish, shape, color, appearance or dimension structure - Appearance	1	P	Change of appearance A) Change in appearance without impact on product integrity B) Change in appearance with impact on product integrity C) Change in appearance with impact on appearance D) Change in appearance with impact on appearance (change of color)	B		B	In combination with PKG-FM-DC-03				
	PKG-FM-DC-05	Changes of inner construction - Finishing	1	P	Change of inner construction	C	e.g. change to different foil supplier	C					
	PKG-FM-DC-06	Changes of inner construction - Isolation System	1	P	Change of inner insulation contact wiring element (against heating)	C	e.g. change of padding material e.g. change of number of inner insulation layers (insulation of construction material increase)	C					
	PKG-FM-DC-07	Changes of inner construction - Surface finish, shape, color, appearance or dimension structure - Packaging	1	P	Change of packaging	B	e.g. change of dimension of inner e.g. change of surface	B					
	PROCESSING - NEW MATERIAL, CRITICAL DIMENSIONS												
	PKG-FM-PR-01	Changes in process technology or manufacturing methods - Packaging	1	P	Change of new thing or handling process (change for better tolerability)	C	e.g. change in new thing process (change, replacement, etc.) e.g. change in handling process (temperature, time, etc.)	C					
	PKG-FM-PR-02	Changes in process technology or manufacturing methods - Terminal Attach	1	P	Change Terminal Attach/Process to welding element for board and substrate	C	e.g. changing and/or generic process, etc. e.g. welding technology	C					Consider ESD, Solderability Test for reflow (SAC) components
	PKG-FM-PR-03	Changes in process technology or manufacturing methods - Welding	1	P	Change of welding, soldering or tempering process	C	e.g. change of tempering temperature	C					
	PKG-FM-PR-04	Changes in process technology or manufacturing methods - Soldering	1	P	Change of soldering process	C	e.g. solder used	C					
Packaging	PKG-FM-PR-05	Packing (shipping specification change (covering of substances))	1	P	Change of packing specification	B	e.g. number of pieces on net	B					
	PKG-FM-PR-06	Change of packing requirements	1	P	Change of packing requirements	B	e.g. change of GDS e.g. change of dry pack assurance (SAC, MILB)	B					
	PKG-FM-PR-07	Change of carrier (tray, net)	1	P	Change of carrier	B	e.g. change of material e.g. change to geometry	B					
	PACKAGING - VISUAL INSPECTION												
Packaging	PKG-FM-PV-01	Change of labeling	1	P	Change of labeling, also manual	B	B) e.g. additional information (Bar S change) B) e.g. change of customer specific information	B					
	PKG-FM-PV-02	Change of product marking	1	P	Marking on device	B	e.g. change of corner of marking e.g. change of position of marking e.g. change of appearance of marking	B					
	PKG-FM-PV-03	Change of packing/marking specification	1	P	Change in marking specification which does not include change of dimensions or material of package	B	e.g. change of documentation in packing specification	B					
LOGISTICS/CAPACITY/TESTING - EQUIPMENT													
Packaging	PKG-FM-ES-01	Production from new equipment which uses different technology or which due to its unique function can be expected to influence the energy of the final product	1	P	Change in process technology which is not already covered by the current process or which is not covered by the current process	C	e.g. implementation of new machine	C					
	PKG-FM-ES-02	Production from new equipment which uses the same technology (replacement equipment or extension of existing equipment)	1	P	Change in process technology which uses the same technology (replacement equipment or extension of existing equipment)	C	e.g. extension of existing machine capacity	C					
	PKG-FM-ES-03	Change in final test equipment (use of different technology)	1	P	Change of final test equipment which uses different technology	C	ICs required for test equipment for serial production	C					
Packaging	PKG-FM-RT-01	Change of manufacturing site (includes transfer as well as technical data, change of process, etc.)	1	P	Change of manufacturing site	B	e.g. extension or change of manufacturing process (see also PKG-FM-DC-03)	B					
	PKG-FM-RT-02	Extension or addition of a manufacturing process step	1	P	Change of manufacturing process	C	e.g. welding / cleaning process e.g. change of process	C					
LOGISTICS/CAPACITY/TESTING - QUARTZ													
Packaging	PKG-FM-QS-01	Change of test coverage used by the supplier to ensure data sheet compliance (e.g., identification of critical test conditions like block, identification of mounting procedure or temping)	1	P	Change of test coverage	C	e.g. change from 100% to 50% test coverage e.g. test flow, reduction from three test flows to two test flows e.g. change in turn-in or in process	C					
QUARTZ CRYSTAL / SAW													
Quartz Crystal / SAW	PKG-QA-MC-01	Any change with impact on agreed technical contractual agreements	1	P	Change of technical contractual agreements	B	e.g. change of technical specification	B					
	PKG-QA-MC-02	Any change with impact on previously manufactured customer, which is not covered in the data sheet	1	P	Change of technical contractual agreements	B	Technical contract (new component version)	B					
QUARTZ													
Quartz Crystal / SAW	PKG-QA-CS-01	Change of parameter (electrical specification (f0, f1, etc.), value), and/or ACDC specification	1	P	Change of electrical parameter (not included - External changes)	A	e.g. change of electrical parameter distribution	A					
	PKG-QA-CS-02	Correction of data sheet or issue of errata	1	P	Change of data sheet or issue of errata	A	e.g. change of data sheet or issue of errata	A					
	PKG-QA-CS-03	Specification of additional parameters	1	P	Specification of additional parameters	A	e.g. adding new (tested) parameter	A					
MATERIAL													
Quartz Crystal / SAW	PKG-QA-MB-01	Change of material composition - Quartz Blank	1	P	Change of material composition	A	e.g. change from quartz to other material	A					
	PKG-QA-MB-02	Change of material composition - Base	1	P	Change of material composition	A	e.g. change from ceramic to other material	A					
	PKG-QA-MB-03	Change of material composition - Lead/Termination	1	P	Change of material composition	B	e.g. change of plating finish (Ag Au, AgPdSn)	B					
	PKG-QA-MB-04	Change of material composition - Sealing	1	P	Change of material composition	B	e.g. change to lead free glue	B					
	PKG-QA-MB-05	Change of material composition - Can/Cap	1	P	Change of material composition	A	e.g. change from metal to ceramic material	A					
	PKG-QA-MB-06	Change of material composition - Blank/Support	1	P	Change of material composition	B	e.g. change from glass to other material	B					
	PKG-QA-MB-07	Change of material composition - Overcoat	1	P	Change of material composition	B	e.g. change from metal to other material	B					
	PKG-QA-MB-08	Change of material composition - Case Setting	1	P	Change of material composition	C	e.g. change from solder paste to adhesive glue	C					
	PKG-QA-MB-09	Change of material composition - Dieattach	1	P	Change of material composition	C	e.g. change from Au-Si to other material	C					
	PKG-QA-MB-10	Change of material composition - Insulator	1	P	Change of material composition	B	e.g. change from other material to other material	B					
	PKG-QA-MB-11	Change of material composition - Marking	1	P	Change of material composition	B	e.g. change of marking material	B					
Quartz Crystal / SAW	PKG-QA-MC-01	Change of supplier of material	1	P	Change of supplier of material	C	e.g. change from one supplier to another	C					
	DESIGN												
	PKG-QA-DC-01	Changes of inner construction - Surface finish, shape, color, appearance or dimension structure - Base	1	P	Change of base design	B	e.g. change of base design	B					
	PKG-QA-DC-02	Changes of inner construction - Surface finish, shape, color, appearance or dimension structure - Lead/Termination	1	P	Change of lead/termination design (change geometry or removal of lead/termination)	B	e.g. change lead design to improve reliability	B					
	PKG-QA-DC-03	Changes of inner construction - Surface finish, shape, color, appearance or dimension structure - Can/Cap	1	P	Change of Can/Cap design	A	e.g. change of Can/Cap design	A					
	PKG-QA-DC-04	Changes of inner construction - Surface finish, shape, color, appearance or dimension structure - Packaging	1	P	Change of packaging design (change the design of the package)	B	e.g. change from traditional to glued carrier (case setting) e.g. change for typical SAC	B					
	PKG-QA-DC-05	Changes of inner construction - Surface finish, shape, color, appearance or dimension structure - Insulator	1	P	Change of insulator design (change the design of the insulator)	B	e.g. change of insulator design (change the design of the insulator) e.g. change of insulator design (change the design of the insulator)	B					
	PKG-QA-DC-06	Changes of inner construction - Quartz Blank	1	P	Change of quartz blank design	C	e.g. change dimension of blank, with plating, electrode, etc.	C					
	PKG-QA-DC-07	Changes of inner construction - Blank Support	1	P	Change of blank support design	C	e.g. change design of blank support	C					
	PROCESS												

Part No.	Change Description	Category	Impact	Priority	Analysis	Process	Material	Design	Test	Assembly	Delivery	Support	Other	Notes
QUARTZ-CEV1-1001	Change in process technology or manufacturing method - Guest Bank	P	Change of Guest Bank process	e.g. Change of sputter or evaporation technology	C									
QUARTZ-CEV1-1002	Change in process technology or manufacturing method - Blank Etching / Cleaning	P	Change of Blank Etch/Clean process (using different / new technology)	e.g. Change from blank etching to plasma wetting	C									
QUARTZ-CEV1-1003	Change in process technology or manufacturing method - Electrode Formation	P	Change of Electrode Formation process	e.g. Change from evaporation to sputtering	C									
QUARTZ-CEV1-1004	Change in process technology or manufacturing method - Trimming	P	Change of Electrode Trimming (Method of final process/trimming)	e.g. Change from evaporation to laser beam	C									
QUARTZ-CEV1-1005	Change in process technology or manufacturing method - Bonding / Annealing	P	Change of Bonding/annealing process. Change of material (new supply contract material or type of bond)	e.g. Change from evaporation to laser beam	C									
QUARTZ-CEV1-1006	Change in process technology or manufacturing method - Cap / Cap Abrasing	P	Change of Cap/Cap abrading process	e.g. Change of abrading method	C									
QUARTZ-CEV1-1007	Change in process technology or manufacturing method - Masking	P	Change of Masking process. Not relevant for blank EMC	e.g. Change of mask/trim process	C									
QUARTZ-CEV1-1008	Change in process technology or manufacturing method - Marking	P	Change of Marking process	e.g. Change from marking to laser marking	B									Not used necessary
QUARTZ-CEV1-1009	Change in process technology or manufacturing method - Aging	P	Change of Aging process. Typical Aging time process in blank	e.g. Change of aging time or temperature	C									
QUARTZ-CEV1-1010	Process change by using new technology	P	Change of process technology	e.g. Change of process technology	C									
PACKING / SHIPPING - VIBRATION / CRITICAL DIMENSIONS														
QUARTZ-CEV1-1011	Change in packaging specification (number of components)	P	Change of packaging specification	e.g. Number of pieces or unit	B									
QUARTZ-CEV1-1012	Change in packaging specification (weight)	P	Change of packaging specification	e.g. Change of weight	B									
QUARTZ-CEV1-1013	Change in packaging specification (material)	P	Change of packaging specification	e.g. Change of material	B									
QUARTZ-CEV1-1014	Change in packaging specification (color)	P	Change of packaging specification	e.g. Change of color	B									
PACKING / SHIPPING - VISUAL INSPECTION														
QUARTZ-CEV1-1015	Change in packing specification (additional)	P	Change of packing specification	e.g. Additional information (RoHS stamp)	B									
QUARTZ-CEV1-1016	Change in packing specification (additional)	P	Change of packing specification	e.g. Additional information (RoHS stamp)	B									
QUARTZ-CEV1-1017	Change in packing specification (additional)	P	Change of packing specification	e.g. Additional information (RoHS stamp)	B									
QUARTZ-CEV1-1018	Change in packing specification (additional)	P	Change of packing specification	e.g. Additional information (RoHS stamp)	B									
LOGISTICS / CAPACITY / TESTING - EQUIPMENT														
QUARTZ-CEV1-1019	Production from a new equipment or which uses a different technology or which due to its unique nature cannot be specifically identified by the final product	P	Change in process technology which is not directly related to the product	e.g. New equipment supplier with different process flow	C									Technical change according to final test requirements. Not according to different process change
QUARTZ-CEV1-1020	Production from a new equipment or which uses a different technology (replacement equipment or replacement of some equipment)	P	Change in process technology which is not directly related to the product	e.g. Replacement of some equipment	C									Technical change according to final test requirements. Not according to different process change
QUARTZ-CEV1-1021	Change in final test equipment that uses a different technology	P	Change of final test equipment which uses different technology	e.g. Change of test program	C									Cap: BSM / data correction
LOGISTICS / CAPACITY / TESTING - PROCESS FLOW														
QUARTZ-CEV1-1022	Manufacturing site order / number of a part of production process to a different location	P	Change of manufacturing site	e.g. Movement or transfer of manufacturing site or process steps to a different location	B									
QUARTZ-CEV1-1023	Extension or addition of a manufacturing process step	P	Change of manufacturing process sequence	e.g. Adding / removing process	C									Discussion should be in respect of production flow
LOGISTICS / CAPACITY / TESTING - GAUGE														
QUARTZ-CEV1-1024	Change of test coverage used by the supplier to ensure data compliance (e.g. administrative/technical measurement flow block, replacement of measuring procedure or sampling)	P	Change of test coverage	e.g. Change from OHS to sample inspection	C									It should be noted that the change is not only for change in blank
ALUMINIUM ELECTRONIC CAPACITORS														
EMC														
QUARTZ-CEV1-1025	No change with respect to approval/good technical agreements	P	Approved to be used for other type of change in process technology	Not relevant for technical evaluation	-									
QUARTZ-CEV1-1026	No change with respect to approval/technical agreement to customer, which is not covered by the main product	P	Technical change from new components terminals, but compatibility on other level	Not relevant for technical evaluation	B									
ENVIRONMENT														
QUARTZ-CEV1-1027	Change of electrical parameter/technical specification (tolerance, value and/or ACDC specification)	P	Change of application relevant information (not included: external changes)	e.g. Higher of electrical parameter distribution	A									Risk assessment depending on change for each application
QUARTZ-CEV1-1028	Correction of data sheet or issue of errors	I	Technical change of product, process or test flow description of product which are not specified in the drawing, which are not specified in the drawing (change of tolerance, which are not specified in the drawing, which are not specified in the drawing)	e.g. Data sheet correction because of new information or improvement	A									
QUARTZ-CEV1-1029	Verification of additional parameters	I	Description of a feature probably covered in the drawing, but not specified in the drawing (e.g. Technical change of the product, which are not specified in the drawing, which are not specified in the drawing)	e.g. Adding new (tested) parameter	A									
MATERIAL														
QUARTZ-CEV1-1030	Change of material composition - Housing	P	Change of housing	e.g. Change of alloy for housing	C									
QUARTZ-CEV1-1031	Change of material composition - Sealing	P	Change of sealing	e.g. Change of rubber compound	C									
QUARTZ-CEV1-1032	Change of material composition - External insulation	P	Change of external insulation	e.g. Change of external insulation (e.g. Dielectric material)	C									
QUARTZ-CEV1-1033	Change of material composition - Lead / Termination	P	Change of lead or solder termination	e.g. Change of lead or solder	B									Based on technical data sheet for lead without setting values
QUARTZ-CEV1-1034	Change of material composition - Internal insulation	P	Change of paper tapes / internal insulation	e.g. Change of paper thickness 50 µm to 40 µm	C									
QUARTZ-CEV1-1035	Change of material composition - Electrolyte	P	Change of electrolyte	e.g. Change of electrolyte	C									
QUARTZ-CEV1-1036	Change of material composition - Tapes Material	P	Change of tape material	e.g. Change of tape / resin material	C									
QUARTZ-CEV1-1037	Change of material composition - Base Plate	P	Change of base plate material	e.g. Change of ceramic material	B									
QUARTZ-CEV1-1038	Change of supplier of material	P	Change of material supplier	e.g. Change of material supplier	C									Technical change according to final test requirements. Not according to different process change. Discussion should be in respect of production flow
DESIGN														
QUARTZ-CEV1-1039	Change of termination, surface finish, shape, color, appearance or dimension structure - Wire Connect	I	Change of wire dimension	e.g. Change from 0.3 to 0.5 mm wire diameter	B									
QUARTZ-CEV1-1040	Change of termination, surface finish, shape, color, appearance or dimension structure - Termination	I	Change of termination appearance for metal capacitors case	e.g. Change from lead to straight	B									
QUARTZ-CEV1-1041	Change of termination, surface finish, shape, color, appearance or dimension structure - Appearance	I	Change of appearance	e.g. Change of color appearance	B									
QUARTZ-CEV1-1042	Change of termination, surface finish, shape, color, appearance or dimension structure - Sealing	I	Change of rubber sealing (lead of shape for EMS)	e.g. Change of profile / design	A									
QUARTZ-CEV1-1043	Change of inner construction - Aluminium Foil	P	Change of inner foil	e.g. Change of foil	C									
QUARTZ-CEV1-1044	Change of inner construction - Separator	P	Change of separator foil	e.g. Change of separator	C									
QUARTZ-CEV1-1045	Change of inner construction - Separator Density	P	Change of separator density	e.g. Change of separator density	C									
QUARTZ-CEV1-1046	Change of inner construction - Inner Connection	P	Change of inner connection	e.g. Change of inner connection	C									
QUARTZ-CEV1-1047	Change of inner construction - Coating Type	P	Change of coating type	e.g. Change of coating	C									
QUARTZ-CEV1-1048	Change of inner construction - Film	P	Change of film type	e.g. Change of film type	C									
PROCESS														
QUARTZ-CEV1-1049	Change in process technology or manufacturing method - Terminal Finish	P	Change of terminal finish process	e.g. Change of plating / wetting liquid	C									Technical change (11) and vibration (12) but for metal components without possible lead
QUARTZ-CEV1-1050	Change in process technology or manufacturing method - Wetting	P	Change of wetting process	e.g. Change of wetting liquid	B									
QUARTZ-CEV1-1051	Change in process technology or manufacturing method - Interconnection	P	Change of interconnection	e.g. Change of interconnection technology	C									Change in interconnection technology for high voltage components only
QUARTZ-CEV1-1052	Change in process technology or manufacturing method - Assembly	P	Change of assembly process	e.g. Change of assembly process	C									It depends on process change
QUARTZ-CEV1-1053	Change in process technology or manufacturing method - Aging / Testing	P	Change of aging/testing process	e.g. Change of aging, testing or temperature of process	C									It depends on process change
QUARTZ-CEV1-1054	Change in process technology or manufacturing method - Trim & Form Feed	P	Change of trim & form process (blank)	e.g. Change of blanking process	B									Substrating may be influenced
QUARTZ-CEV1-1055	Change in process technology or manufacturing method - Trim & Form BMD	P	Change of trim & form process (BMD)	e.g. Change of blanking process	B									Substrating may be influenced

Product	Category	Change Description	Impact	Complexity	Frequency	Process	Cost	Quality	Quantity	Lead Time	Warranty	Service	Other	Notes	
PACING / SHIPPING - NEW MATERIAL, CRITICAL DIMENSIONS	IND-AU-PR-01	Process mapping for wiring with specifications	P	P	P									no process control	
	IND-AU-PR-01	Packing / shipping specification-change (lessening of tolerances)	P	P	P									e.g. number of pieces on reel	
	IND-AU-PR-02	Dry-pack requirements change	P	P	P									e.g. change of MS, e.g. change in dry pack assurance (MS, MB)	
	IND-AU-PR-03	Change of carrier (rig, reel)	P	P	P									e.g. change to material, e.g. change to assembly	
	PACING / SHIPPING - VISUAL INSPECTION	IND-AU-PV-01	Change of labeling, also in reel	I	P	P									If e.g. additional information (Start/End string) (If e.g. change of customer specific information)
		IND-AU-PV-02	Change of product marking	I	P	P									e.g. change of corner of marking, e.g. change of material of marking, e.g. change of appearance of marking
		IND-AU-PV-03	Change of packing/shipping specification	P	P	P									Change in packing/shipping specification which does not affect technical change of dimensions or material of the parts
	LOGISTICS / CAPACITY / TESTING - EQUIPMENT	IND-AU-EG-01	Production from a new experimental which uses a different technology which due to its unique form factor can be expected to influence the integrity of the final product	P	P	P									e.g. change to process which is not already covered in the test plan
		IND-AU-EG-02	Production from a new experimental which uses the same basic technology / replacement equipment or selection of existing equipment pool	P	P	P									ICN required for additional equipment for selected component production
		IND-AU-EG-03	Change in final test equipment type that uses a different technology	P	P	P									ICN required for test-equipment for selected parameters
	LOGISTICS / CAPACITY / TESTING - PROCESS FLOW	IND-AU-PF-01	Manufacturing site transfer or movement of a production process to a different installation	P	P	P									e.g. investment in transfer / manufacturing plant
		IND-AU-PF-02	Dimensional or addition of a manufacturing process sequence	P	P	P									e.g. change of sequence of process steps
IND-AU-PF-03		Continuation of final electrical measurement / test from track	I	P	P									ICN required for identification test-reactions for components	
IND-AU-GG-01		Change of test coverage used by the supplier to ensure data completeness (e.g., administration of electrical measurement checklist, release of measurement of monitoring procedure or sampling)	P	P	P									e.g. change from 100% to sample inspection, e.g. test from track, reduction from three to two test parameters, e.g. change in test plan or process	
MATERIAL	IND-MC-01	No change with impact on agreed open technical contractual agreements	P	P	P									not relevant for technical evaluation	
	IND-MC-02	No change with impact on processability/manufacturability by customer, which is not covered in the terms	P	P	P									Technical measures ensure compliance terminals	
	IND-MC-03	Change of electrical parameter / selection of test equipment	P	P	P									Risk assessment depending on change for auto-connection	
	IND-MC-04	Correction of data sheet or value of stress	I	P	P									e.g. data sheet correction because of new information about component behavior	
	IND-MC-05	Declaration of a new or previously covered additional parameter	I	P	P									e.g. adding new (defined) parameter	
	IND-MC-06	Change of material composition - Ceramic Glaze	P	P	P									e.g. change of glaze composition	
MATERIAL	IND-MC-07	Change of material composition - Ceramic	P	P	P									e.g. change to additive amount	
	IND-MC-08	Change of material composition - Inner Electrode	P	P	P									e.g. change from Ag/Pt material to Ag/Pt material	
	IND-MC-09	Change of material composition - Dielectric	P	P	P									Risk assessment on application level of protection with other material options	
	IND-MC-10	Change of material composition - Lead Termination	P	P	P									Risk assessment needed to ensure compatibility of soldering process	
	IND-MC-11	Change of material composition - Lead Termination	P	P	P									e.g. change from Sn to pure Sn	
	IND-MC-12	Change of material composition - Pad	P	P	P									e.g. for 2nd source package	
DESIGN	IND-MC-DE-01	Change of termination, surface finish, shape, color, appearance or dimension structure - Lead Connector	I	P	P									e.g. change lead diameter from 0.5 to 0.4 mm	
	IND-MC-DE-02	Change of termination, surface finish, shape, color, appearance or dimension structure - Termination Area	I	P	P									e.g. change termination shape / thickness, e.g. change termination dimension	
	IND-MC-DE-03	Change of termination, surface finish, shape, color, appearance or dimension structure - Internal Connection	I	P	P									e.g. change from external connection to internal connection	
	IND-MC-DE-04	Change of termination, surface finish, shape, color, appearance or dimension structure - Appearance	I	P	P									e.g. change of color or component finish in combination with other changes	
	IND-MC-DE-05	Change of inner connection - Electrode	P	P	P									e.g. change of electrode design	
	IND-MC-DE-06	Change of inner connection - Layer Thickness	P	P	P									e.g. change from 4.5 to 4.0 μm	
	IND-MC-DE-07	Change of inner connection - Number of Layers	P	P	P									see also layer thickness	
	PROCESS	IND-MC-PR-01	Change in process technology or manufacturing method - Lamination	P	P	P									e.g. stamp press to isostatic press
		IND-MC-PR-02	Change in process technology or manufacturing method - Fining	P	P	P									e.g. temper down and/or new and/or atmosphere, e.g. thermal treatment
		IND-MC-PR-03	Change in process technology or manufacturing method - Dicing	P	P	P									e.g. change from cutting to sawing
		IND-MC-PR-04	Change in process technology or manufacturing method - Termination	P	P	P									e.g. change from termination by printing to spray of termination paste
		IND-MC-PR-05	Change in process technology or manufacturing method - Electrode apply	P	P	P									e.g. change of electrode lay down method
IND-MC-PR-06		Change in process technology or manufacturing method - Assembly	P	P	P									e.g. adding method for which is relevant or not relevant for production	
PACING / SHIPPING - NEW MATERIAL, CRITICAL DIMENSIONS	IND-MC-PR-07	Process mapping for wiring with specifications	P	P	P									no process control	
	IND-MC-PR-01	Packing / shipping specification-change (lessening of tolerances)	P	P	P									e.g. number of pieces on reel	
	IND-MC-PR-02	Dry-pack requirements change	P	P	P									e.g. change of MS, e.g. change in dry pack assurance (MS, MB)	
	IND-MC-PR-03	Change of carrier (rig, reel)	P	P	P									e.g. change to material, e.g. change to assembly	
	PACING / SHIPPING - VISUAL INSPECTION	IND-MC-PV-01	Change of labeling, also in reel	I	P	P									If e.g. additional information (Start/End string) (If e.g. change of customer specific information)
		IND-MC-PV-02	Change of product marking	I	P	P									e.g. change of corner of marking, e.g. change of material of marking, e.g. change of appearance of marking
		IND-MC-PV-03	Change of packing/shipping specification	P	P	P									Change in packing/shipping specification which does not affect technical change of dimensions or material of the parts
	LOGISTICS / CAPACITY / TESTING - EQUIPMENT	IND-MC-EG-01	Production from a new experimental which uses a different technology which due to its unique form factor can be expected to influence the integrity of the final product	P	P	P									e.g. change from old technology, e.g. change from test to dry technology
		IND-MC-EG-02	Production from a new experimental which uses the same basic technology / replacement equipment or selection of existing equipment pool	P	P	P									ICN required for additional equipment for selected component production
		IND-MC-EG-03	Change in final test equipment type that uses a different technology	P	P	P									ICN required for manual handling processes

Qualification Results Summary of LT8650S at Vanguard International Semiconductor

QUALIFICATION STATUS – LT8650S 32L LQFN			
TEST	SPECIFICATION	SAMPLE SIZE	RESULTS
Solder Heat Resistance (SHR)*	JEDEC/IPC <i>J-STD-020</i>	1*231	Pass
Highly Accelerated Stress Test (HAST)*	JEDEC <i>JESD22-A110</i>	1*77	Pass
Temperature Cycling (TC)*	JEDEC <i>JESD22-A104</i>	1*77	Pass
Unbiased Highly Accelerated Stress Test (UHAST)*	JEDEC <i>JESD22-A102</i>	1*77	Pass
High Temperature Storage Life (HTSL)	JEDEC <i>JESD22-A103</i>	1*45	Pass
Latch-Up	JEDEC <i>JESD78</i>	> ±100mA	Pass
Electrostatic Discharge <i>Human Body Model</i>	ESDA/JEDEC <i>JS-001</i>	3/voltage	Pass 4000V
Electrostatic Discharge <i>Field-Induced Charged Device Model</i>	JEDEC <i>JESD22-C101</i>	3/voltage	Pass 2000V

*Preconditioned per JEDEC/IPC J-STD-020

Qualification Results Summary of LT8650S at Vanguard International Semiconductor

QUALIFICATION STATUS – LT8650SP 32L LQFN			
TEST	SPECIFICATION	SAMPLE SIZE	RESULTS
High Temperature Operating Life (HTOL)	JEDEC <i>JESD22-A108</i>	3*77	Pass
Solder Heat Resistance (SHR)*	JEDEC/IPC <i>J-STD-020</i>	3*231	Pass
Highly Accelerated Stress Test (HAST)*	JEDEC <i>JESD22-A110</i>	3*77	Pass
Temperature Cycling (TC)*	JEDEC <i>JESD22-A104</i>	2*77	Pass
Unbiased Highly Accelerated Stress Test (UHAST)*	JEDEC <i>JESD22-A102</i>	3*77	Pass
High Temperature Storage Life (HTSL)	JEDEC <i>JESD22-A103</i>	1*45	Pass

*Preconditioned per JEDEC/IPC J-STD-020

LT8650S

ABSOLUTE MAXIMUM RATINGS

(Note 1)

V_{IN1} , V_{IN2} , EN/UV1, EN/UV2, PG1, PG2.....	42V
BIAS.....	30V
FB1, FB2, SS1, SS2	4V
VC1, VC2.....	3.5V
SYNC.....	6V

Operating Junction Temperature Range (Note 2)

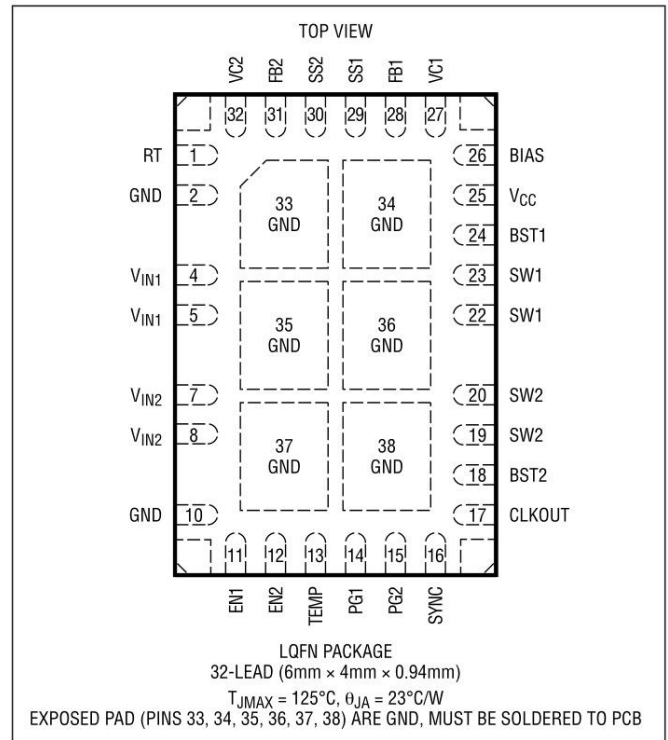
LT8650SE.....	-40 to 125°C
LT8650SI.....	-40 to 125°C

Storage Temperature Range -65 to 150°C

Maximum Reflow (Package Body)
Temperature..... 260°C

Absolute Maximum Ratings will now show H Grade information.

PIN CONFIGURATION



ORDER INFORMATION

<http://www.linear.com/product/LT8650S#orderinfo>

PART NUMBER	PAD OR BALL FINISH	PART MARKING		PACKAGE** TYPE	MSL RATING	TEMPERATURE RANGE (SEE NOTE 2)
		DEVICE	FINISH CODE			
LT8650SEV#PBF	Au (RoHS)	8650SV	e4	LQFN (Laminate Package with QFN Footprint)	3	-40°C to 125°C
LT8650SIV#PBF						-40°C to 125°C

- Device temperature grade is indicated by a label on the shipping container.
- Pad or ball finish code is per IPC/JEDEC J-STD-609.
- Terminal Finish Part Marking: www.linear.com/leadfree
- Parts ending with PBF are RoHS and WEEE compliant.
- Recommended PCB Assembly and Manufacturing Procedures: www.linear.com/umodule/pcbassembly
- Package and Tray Drawings: www.linear.com/packaging

**The LT8650S package has the same dimensions as a standard 6mm x 4mm QFN package

Order Information updated to show H Grade. LT8650SHV#PBF and LT8650SHV#WPBF

ELECTRICAL CHARACTERISTICS

The ● denotes the specifications which apply over the full operating temperature range, otherwise specifications are at $T_A = 25^\circ\text{C}$.

PARAMETER	CONDITIONS	MIN	TYP	MAX	UNITS
Minimum Input Voltage		●	2.6	3	V
V_{IN1} Quiescent Current in Shutdown	$V_{EN/UV1} = V_{EN/UV2} = 0V$, $V_{SYNC} = 0V$	●	1.7	4	μA
				8 10	μA
$V_{IN1} + V_{CC}$ Quiescent Current in Sleep with Internal Compensation	$V_{EN/UV1} = V_{EN/UV2} = 2V$, $V_{FB1} = V_{FB2} > 0.8V$, $V_{VC1} = V_{VC2} = V_{CC}$, $V_{SYNC} = 0V$	●	3.7	8	μA
				16 20	μA
$V_{IN1} + V_{CC}$ Quiescent Current in Sleep with External Compensation	$V_{EN/UV1} = V_{EN/UV2} = 2V$, $V_{FB1} = V_{FB2} > 0.8V$, $V_{VC1} = V_{VC2} = \text{Float}$, $V_{SYNC} = 0V$	●	90	120	μA
				140	μA

Rev A

ELECTRICAL CHARACTERISTICS The ● denotes the specifications which apply over the full operating temperature range, otherwise specifications are at $T_A = 25^\circ\text{C}$.

PARAMETER	CONDITIONS	MIN	TYP	MAX	UNITS	
$V_{IN1} + V_{CC}$ Quiescent Current when Active	$V_{EN/UV1} = V_{EN/UV2} = 2V$, $V_{FB1} = V_{FB2} > 0.8V$, $V_{VC1} = V_{VC2} = V_{CC}$, $V_{SYNC} = 3.4V$	●	5	7	mA	
V_{IN} Current in Regulation	$V_{IN} = 12V$, $V_{OUT} = 3.3V$, Output Load = $100\mu A$, $V_{VC1} = V_{VC2} = V_{CC}$, $V_{SYNC} = 0V$ $V_{IN} = 12V$, $V_{OUT} = 3.3V$, Output Load = $1mA$, $V_{VC1} = V_{VC2} = V_{CC}$, $V_{SYNC} = 0V$		45 350	75 550	μA μA	
Feedback Reference Voltage		●	0.794 0.790	0.800 0.810	V V	
Feedback Voltage Line Regulation	$V_{IN} = 4.0V$ to $36V$		0.004	0.02	%/V	
Feedback Pin Input Current	$V_{FB} = 0.8V$		-20	20	nA	
Minimum On-Time	$I_{LOAD} = 3A$, $SYNC = 3.4V \Rightarrow 2V$	●	40	60	ns	
Oscillator Frequency	$R_T = 133k$ $R_T = 35.7k$ $R_T = 15k$	● ● ●	270 0.95-0.94 1.85	300 1.0 2.00	330 1.06 2.15	kHz MHz MHz
Top Power NMOS Current Limit		●	10	12	14	A
Bottom Power NMOS Current Limit			6.5	8.5	10.5	A
SW Leakage Current	$V_{IN} = 42V$, $V_{SW} = 0V, 42V$		-2	2	μA	
EN/UV Pin Threshold	EN/UV Falling	●	0.7	0.74	0.78	V
EN/UV Pin Hysteresis			30		mV	
EN/UV Pin Current	$V_{EN/UV} = 2V$		-20	20	nA	
PG Upper Threshold Offset from V_{FB}	V_{FB} Falling	●	5.5-5.4 7.5	7.5-7.2	9	%
PG Lower Threshold Offset from V_{FB}	V_{FB} Rising	●	0.5-9.3 -7.5	-6-5.7	%	
PG Hysteresis			0.3		%	
PG Leakage	$V_{PG} = 12V$		-40	40	nA	
PG Pull-Down Resistance	$V_{PG} = 0.1V$	●	600	1200	Ohm	
SYNC Threshold	SYNC DC and Clock Low Level Voltage SYNC Clock High Level Voltage SYNC DC High Level Voltage		0.4	1.5 2.8	V V V	
SYNC Pin Current	$V_{SYNC} = 6V$		120		μA	
SS Source Current		●	1.0	2.0	3.0	μA
SS Pull-Down Resistance	Fault Condition, $SS = 0.1V$		200		Ω	
Error Amplifier Transconductance	$V_C = 1.25V$		0.9		mS	
VC Source Current	$V_{FB} = 0.6V$, $V_{VC} = 1.25V$		170	185	μA	
VC Sink Current	$V_{FB} = 1.0V$, $V_{VC} = 1.25V$		170	185	μA	
VC Pin to Switch Current Gain			9.6		A/V	
TEMP Output Voltage	$I_{TEMP} = 0\mu A$, Temperature = 25°C $I_{TEMP} = 0\mu A$, Temperature = 125°C		190 1100	250 1200	310 1300	mV mV

Note 1: Stresses beyond those listed under Absolute Maximum Ratings may cause permanent damage to the device. Exposure to any Absolute Maximum Rating condition for extended periods may affect device reliability and lifetime.

Note 2: The LT8650SE is guaranteed to meet performance specifications from 0°C to 125°C junction temperature. Specifications over the -40°C to 125°C operating junction temperature range are assured by design, characterization, and correlation with statistical process controls. The LT8650SI is guaranteed over the full -40°C to 125°C operating junction temperature range. High junction temperatures degrade operating lifetimes. Operating lifetime is derated at junction temperatures greater

than 125°C . The junction temperature (T_J , in $^\circ\text{C}$) is calculated from the ambient temperature (T_A in $^\circ\text{C}$) and power dissipation (P_D , in Watts) according to the formula:

$$T_J = T_A + (P_D \cdot \theta_{JA})$$

where θ_{JA} (in $^\circ\text{C}/\text{W}$) is the package thermal impedance.

Note 3: This IC includes overtemperature protection that is intended to protect the device during overload conditions. Junction temperature will exceed 150°C when overtemperature protection is active. Continuous operation above the specified maximum operating junction temperature will reduce lifetime